



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450
www.uspto.gov

BIBDATASHEET

CONFIRMATION NO. 9751

Bib Data Sheet

SERIAL NUMBER 10/670,855	FILING DATE 09/25/2003 RULE	CLASS 451	GROUP ART UNIT 3723	ATTORNEY DOCKET NO. SAM-0225DIV
-----------------------------	---------------------------------------	--------------	------------------------	---------------------------------------

APPLICANTS

Jae-Phil Boo, Suwon, KOREA, REPUBLIC OF;
Jun-Gyu Ryu, Seoul, KOREA, REPUBLIC OF;
Sang-Seon Lee, Yongin-shi, KOREA, REPUBLIC OF; Sun-Wung Lee, Yongin-shi, KOREA, REPUBLIC OF;

**** CONTINUING DATA ******* *AD*
This application is a DIV of 09/877,922 06/07/2001 PAT 6,652,362

**** FOREIGN APPLICATIONS ******* *AD*
REPUBLIC OF KOREA 00-69983 11/23/2000
REPUBLIC OF KOREA 01-11055 03/03/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
**** 12/18/2003**

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <i>AD</i> Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 18	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 4
--	--	---	-------------------------	-----------------------	----------------------------

ADDRESS
Mills & Onello LLP
Suite 605
Eleven Beacon Street
Boston, MA
02108

TITLE
Apparatus for polishing a semiconductor wafer and method therefor

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
RECEIVED	No. _____ for following:	